Supporting Information

Hydrogen-induced Topotactic Phase Transformations of Cobaltite Thin Films

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1. XRD profiles

The ω -2 θ XRD curves shown in **Figure S1** provide further details on the temperature dependence of the hydrogenated topotactic transformation of the LSCO films. The half-order peaks originating from the H-BM phase (shaded in orange) only exist at intermediate hydrogenation temperatures (from 170 °C to 290 °C) and the perovskite peaks (shaded in blue) shift to lower angles (forming the H-OD-P phase) then nearly back to its initial 2θ value (H-P phase) with increasing temperature.



Figure S1. XRD profiles as a function of hydrogenation temperatures ranging from 80 °C to 400°C.

2. HAADF-STEM image

The top surface is P phase dominate while the bulk of the film is in the BM phase.



Figure S2. (a) HAADF-STEM image of the H-BM film highlighting the bulk H-BM and surface P phases, and the Au coating. (b) Cropped STEM ADF image focusing on the top part of the film. STEM EELS mapping performed in the green rectangle. (c) EELS spectra of the O-K and Co $L_{2,3}$ edges denoised using principal component analysis keeping the first 15 components. The EELS spectra are averaged over the areas shown in (b) following the same color code as in the plots. (d) Denoised EELS spectra averaged horizontally from the top to the bottom of the green box in (b). The colored arrows point to features of interests changing along the line profile.

3. DFT calculations



Figure S3. Representative sampled hydrogen doping configurations (initial atomic positions before relaxation). Color schemes for elements: La: green, Sr: yellow, Co: blue, O: red, H: white (pointed by arrows). c1 and c2 are H₂ molecular adsorption cases, where the H₂ molecules are in between 1:1 Sr:La ratio planes and 1:3 Sr:La ratio planes, respectively; H₂ molecules orient flat along the short axis. S2-s12: H₂ molecule decompose to two hydrogen atoms at different lattice sites: s2: two randomly placed hydrogen atoms in the unit cell; s3: two hydrogen atoms bond to oxygen ions that form a 90° in-plane O-Co-O bond angle; s9 and s10 (not shown): two hydrogen atoms bond to oxygen ions that form a 180° in-plane O-Co-O bond angle, with different Sr:La local ratio environment; s12: two hydrogen atoms bond to oxygen ions that form a 180° in-plane O-Co-O bond angle, ions that form 180° out-of-plane O-Co-O bond angle. In-plane is formed by shorter axes and the out-of-plane direction is along the longer axis.

Configurations	Δ <i>E_{fH}</i> (eV) 0 K	Δ <i>E_{fH}</i> (eV) 273 K	Δ <i>E_{fH}</i> (eV) 473 K	Co ²⁺ : Co ³⁺ : Co ⁴⁺
c1 (relaxed to 90° HO-Co-OH bonding configuration)	-1.33	-1.36	-1.38	0:6:2
c2 (relaxed to 180° HO-Co- OH bonding configuration)	-0.99	-1.02	-1.04	0:6:2
s2	-0.52	-0.54	-0.56	0:5:3
s3	-1.11	-1.14	-1.16	1:3:4
s9	-1.02	-1.05	-1.07	0:6:2
s10	-1.21	-1.24	-1.26	0:5:3
s12 (relaxed to hydrogen bonded to oxygen ions at different octahedral layers)	-0.61	-0.64	-0.65	0:4:4

Table S1 Calculated formation energy of hydrogen doping (ΔE_{fH}) at different temperatures at 0.3 MPa (experimental pressure) after structural relaxation, using **Eqn. S1** and **S2**.

All the structures with hydrogen doping were initialized with ferromagnetic ordering, and relaxation of inner atomic coordinates were performed without unit cell volume optimization. The formation energy of hydrogen doping ΔE_{fH} is calculated as:

$$\Delta E_{fH} = E_{N+i} - E_N - i * \mu_H \tag{Eqn. S1}$$

$$\mu_{\rm H} = \frac{1}{2} \mu_{\rm H_2} = \frac{1}{2} * \left(E_{H_2}^{\rm total} + kT ln\left(\frac{p}{p^0}\right) \right)$$
(Eqn. S2)

where E_{N+i} the total energy of relaxed structures after doping with *i* number of hydrogen atoms, E_N the total energy of the pristine structure, and μ_H the chemical potential of hydrogen atom. We calculated ΔE_{fH} at 0 K with $E_{H_2}^{\text{total}}$ term (total energy of a hydrogen molecule), and then add temperature *T*, H₂ partial pressure *P* effect through $kT ln\left(\frac{p}{p^0}\right)$, where $p^0=1$ atm.

The ratio between the number of Co^{2+} : Co^{3+} : Co^{4+} valence states are obtained from the calculated magnetic moment of Co ions, where we have assigned magnetic moment <1 μ_B to be Co^{2+} (spin state S=1), between 1~2 μ_B to be Co^{3+} (spin state S=2) and >=2 μ_B to be Co^{4+} (spin state S=3). Such an assignment gives the correct 5 Co^{3+} : 3 Co^{4+} ratio in the pristine structure where we have 5 La:3 Sr.

Table S2 Calculated oxygen vacancy formation energy (ΔE_{f0}) with the presence of hydrogen after cell optimization, using **Eqn. S3** and **S4**.

Configurations	
oxygen attached to H is removed	0.95
oxygen next to the OH bond is removed	-0.43
oxygen in the neighboring octahedral CoO ₆ layers to the OH bond is removed	
oxygen in the next neighboring octahedral CoO ₆ layers to the OH bond is removed	0.95

All the structures with hydrogen doping were initialized with ferromagnetic ordering, and the long axis of the cell is allowed to change during structural optimization, which corresponds to the varying out-of-plane axis in the thin-film samples. Similar to Eqn. S1 and S2, here the formation energy of oxygen vacancy formation energy ΔE_{f0} with the presence of hydrogen doping is calculated as:

$$\Delta E_{fO} = E_{N-j+i} - E_N + j * \mu_O - i * \mu_H$$
 (Eqn. S3)

$$\mu_0 = \frac{1}{2}\mu_{0_2} = \frac{1}{2} * \left(E_{0_2}^{\text{total}} + kT ln\left(\frac{p}{p^0}\right)\right)$$
(Eqn. S4)

where E_{N-j+i} the total energy of relaxed structures after removing *i* number of oxygen atoms while keeping j number of hydrogen atoms, E_N the total energy of the pristine structure, and μ_0 the chemical potential of hydrogen atom. We calculated ΔE_{f0} at 0 K with $E_{H_2}^{\text{total}}$ term (total energy of an oxygen molecule in triplet spin state).